



PATENT  
20063/OG03-046

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**Applicant:**

In Su Kim

Serial No.: 10/758,188

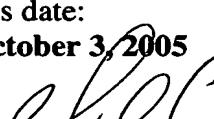
## **For: Methods of Fabricating Semiconductor Devices**

Filed: January 15, 2004

Group Art Unit: 2891

**Examiner: Bradley Smith**

I hereby certify that this paper is  
being deposited with the United  
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mail, postage prepaid, in an  
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Amendment, Commissioner for  
Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450, on  
this date:  
**October 3, 2005**



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## **RESPONSE TO THE OFFICE ACTION DATED JULY 1, 2005**

**Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

Sir:

In response to the Office action dated July 1, 2005, please enter the following amendments and consider the following remarks:

**Amendments to the Specification** begin on page 2 of this paper.

**The Status of the Claims** is reflected in the listing of claims that begins on page 3 of this paper.

**Amendments to the Drawings begin on page 5 of this paper.**

**Remarks begin on page 6 of this paper.**

**An Appendix** including amended drawing figures is attached following page 7 of this paper.